

## OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

## Supplemental Application Data Sheet

<b>Application Informatio</b>	App	licat	ion	Inforr	natio	n
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**Application Type::** 

Regular

Subject Matter::

Utility

CD-ROM or CD-R:

None

Title::

METHOD OF MANUFACTURING THIN FILM ELEMENT, THIN FILM TRANSISTOR CIRCUIT SUBSTRATE, ACTIVE MATRIX DISPLAY DEVICE, ELECTRO-OPTICAL DEVICE, AND

**ELECTRONIC APPARATUS** 

Attorney Docket Number::

118319

**Total Drawing Sheets::** 

8

Small Entity::

No

**Applicant Information** 

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

**Full Capacity** 

Given Name::

Mutsumi

Family Name::

**KIMURA** 

City of Residence::

Kyotanabe-shi

Country of Residence::

Japan

## **Correspondence Information**

Correspondence Customer Number::

25944

Foreign Priority	y Information			
Country::	Application Number::	Filing Date::	Priority Claimed::	
Japan	2003-019126	1/28/2003	Yes	
Assignee Infor	mation			
Assignee Name::		SEIKO EPSON CORPORATION		
Street of mailing address::		4-1, NISHISHINJUKU 2-CHOME		
		SHINJUKU-KU		
City of mailing a		TOKYO		
Country of maili	ng address::	JAPAN		
Postal or Zip Co	ode of mailing address::	163-0811		